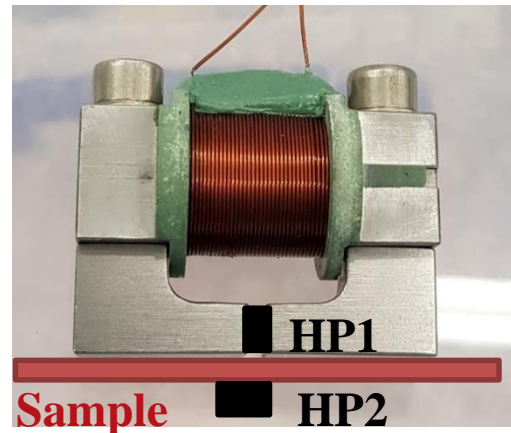
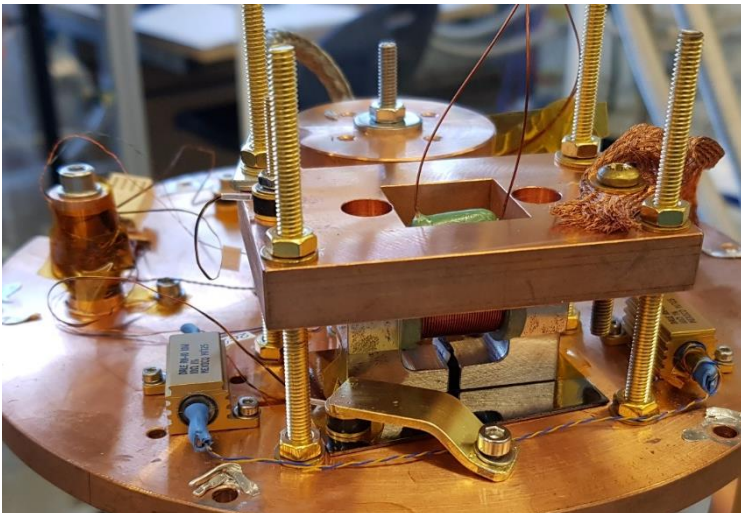


# Results of laser polishing using the field penetration experiment

Daniel Turner  
Lancaster University  
Daresbury Laboratory

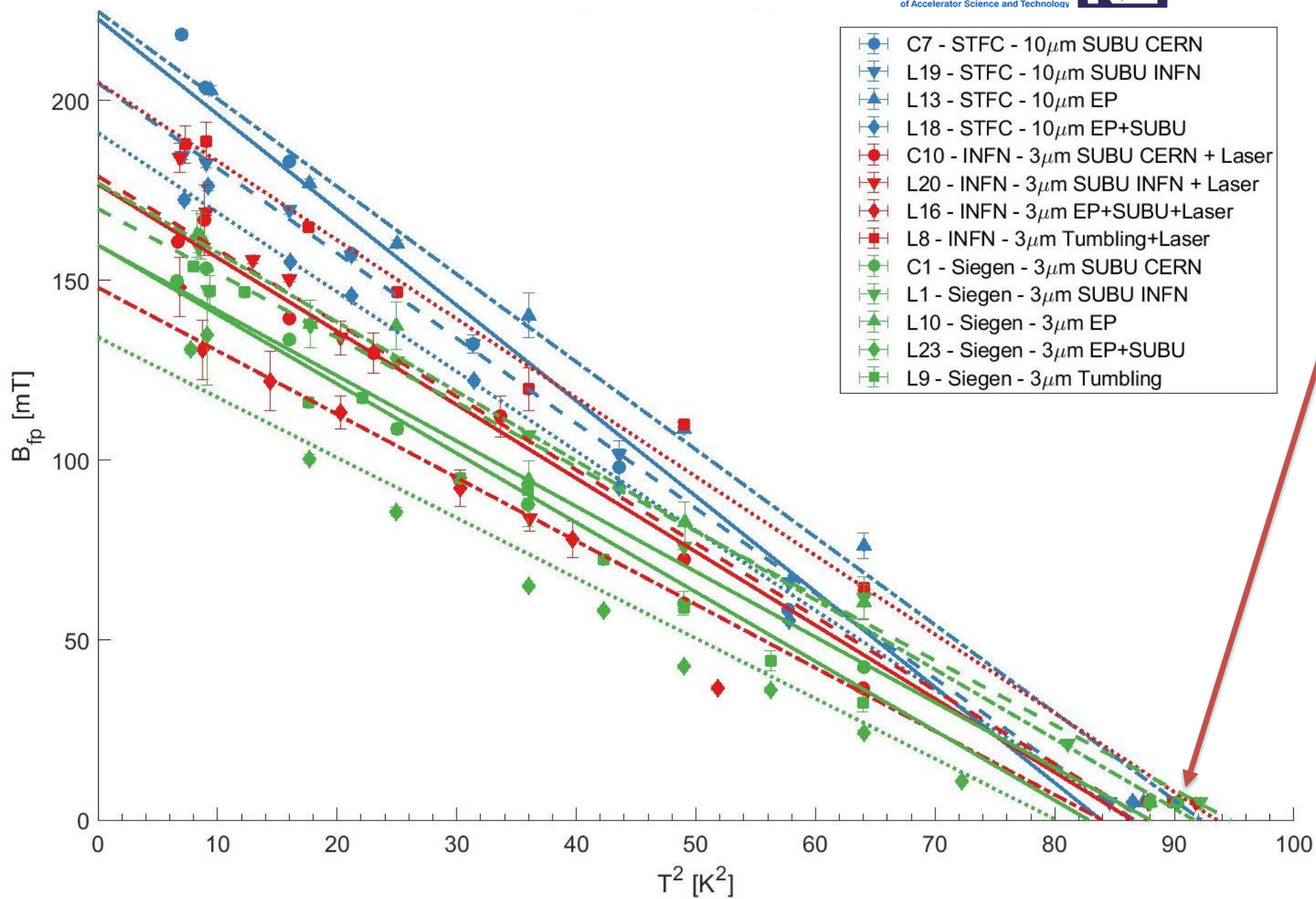
# Laser polished samples

- Nb samples deposited as part of ARIES WP15 sent to RTU for laser polishing.
  - 3 Samples from STFC, and all 5 from Siegen. Samples deposited by INFN not sent as they had already been laser polished in the first test in the field penetration facility.
  - 3/5 STFC samples laser polished
- Samples have been returned, tested, analysed, and compared to the previous results.



## Reminder

- DC magnetic field parallel to the surface
- Field local to the sample surface
  - Avoid edge effect.
  - Allow possibility if sample scanning.
- Magnetic field applied from one side of the sample to the opposing side, similar to an SRF cavity.
- Applied and penetrated field measured by Hall probe sensors
- 50×45 mm maximum, or a 50 mm diameter disk.



- New analysis method is now used, so the old data (pre-laser polish) had to be re-analysed, with the data presented to the left.
- Data includes the  $T_c$  measurement by Bratislava.
- Assuming a linear fit for  $B_{fp}$  as a function of  $T^2$ ,  $B_{fp}(0 \text{ K})$  and  $T_c$  is extrapolated.
  - $T_c$  is not as accurate compared to VSM.
- Results are shown by institution at the end of the paper, for both pre and post laser treatment

# Effect of substrate polishing on $B_{fp}$

STFC	Siegen	INFN (with laser polishing sample surface)	
EP (224.7±8.5)	EP (177.0±6.1)		Largest $B_{fp}$ (0 K)
		Tumbling (205.0±7.8)	
SUBU CERN (222.6±0.9)	SUBU INFN (169.9±5.1)	SUBU INFN (178.9±2.2)	
SUBU INFN (204.8±6.9)	SUBU CERN (159.7±1.4)	SUBU CERN (176.7±4.3)	
-	Tumbling (159.8±1.6)		
EP + SUBU (191.0±4.3)	EP + SUBU (134.2±1.1)	EP + SUBU (148.0±3.7)	Lowest $B_{fp}$ (0 K)

[Magnetic Field Penetration of Niobium Thin Films Produced by the ARIES Collaboration](#) – (Click link for SRF 21 poster)

**Note:** These results were analysed using a different technique.

**Note:** The effect of polishing has slightly changed compared to previous report due to the change in analysis method

# Laser treatment parameters

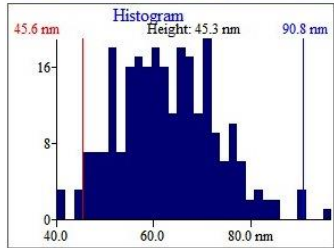
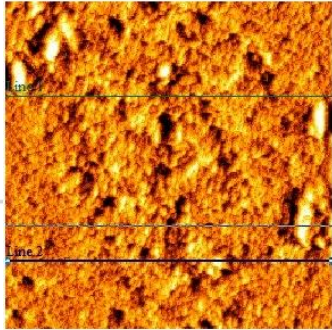
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- All samples sent for laser polishing had the same parameters for treatment:
  - Wavelength: 1,063 nm
  - Intensity: 70 MW/cm<sup>2</sup>
  - Pulse duration: 6ns
  - Dose: 66 J/cm<sup>2</sup>
  - Step: 5 nm
  - Frequency: 10 Hz
  - Beam diameter: 3mm
- Samples treated:
  - STFC: C7 - SUBU CERN, L13 – EP, L18 – EP + SUBU
  - Siegen: C1 – SUBU CERN, L1 – SUBU INFN, L10 – EP, L23 – EP + SUBU, L9 - Tumbling
- Surface characterisation by Artur has been reported at the last IFAST meeting, and are shown again over the next few slides

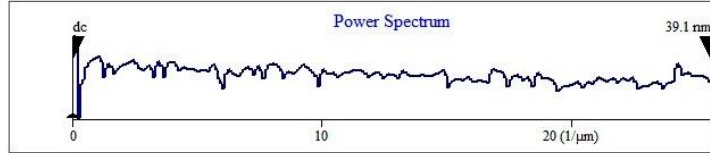
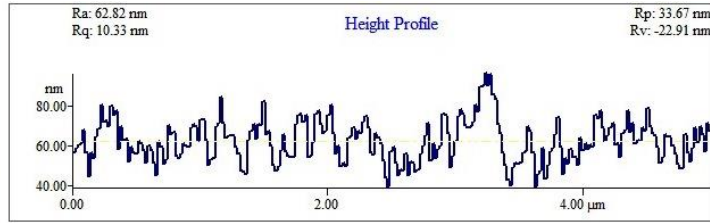


# C1 Siegen - SUBU CERN

(191,80) x: 3.73 μm y: 1.563 μm z: 0.06438 μm



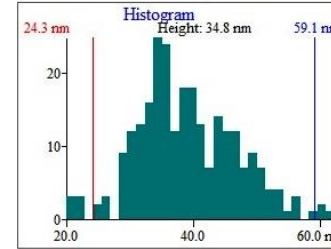
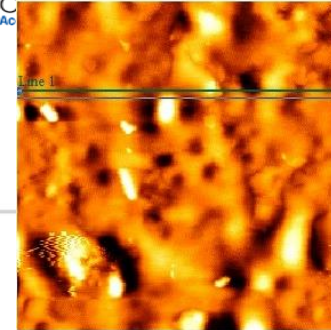
## Nonirradiated



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	55.41 nm	10.93 nm	8.856 nm	62.82 nm	63.08 nm	5.474 μm	@30.0% 69.45
Line 2	<b>56.58 nm</b>	<b>10.33 nm</b>	<b>8.309 nm</b>	<b>62.82 nm</b>	<b>61.74 nm</b>	<b>5.388 μm</b>	<b>@30.0% 68.00</b>
Delta [.]							

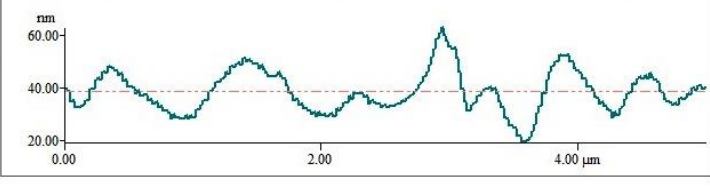


(202,181) x: 3.95 μm y: 3.535 μm z: 0.04332 μm



# Irradiated

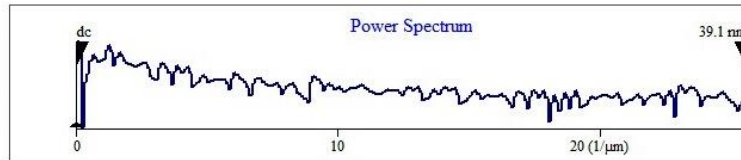
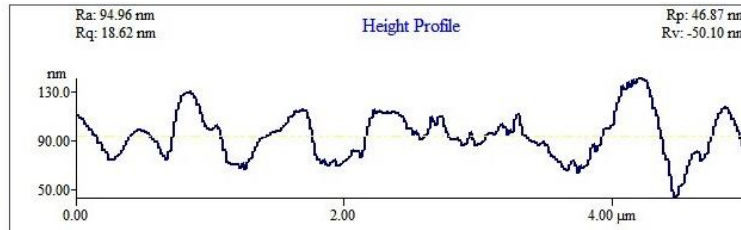
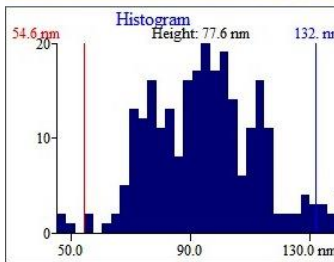
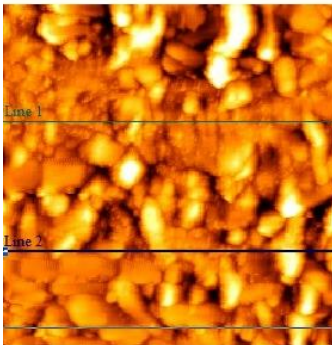
Ra: 39.11 nm Rq: 7.852 nm Rp: 24.32 nm Rv: -19.13 nm



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	43.46 nm	7.852 nm	6.272 nm	39.11 nm	38.34 nm	5.145 μm	@30.0% 43.42
Delta [.]							

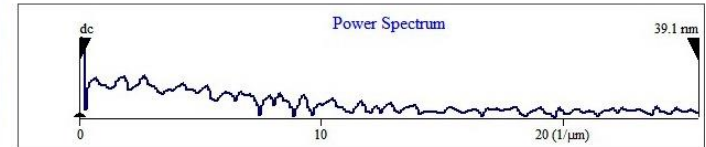
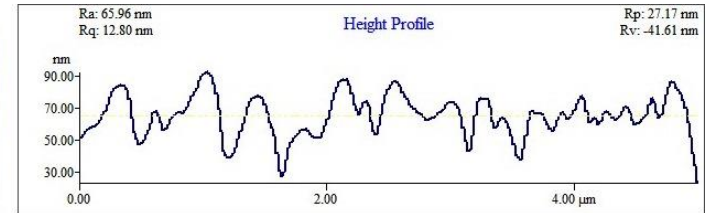
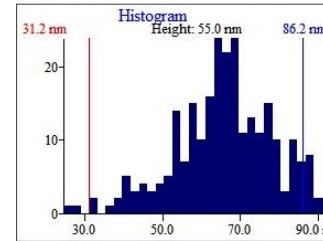
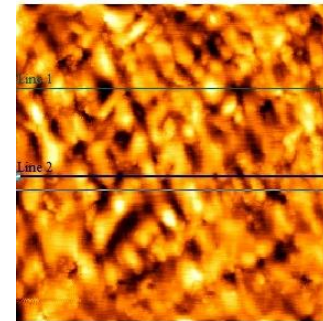
# C7 STFC - SUBU CERN

(247,15) x: 4.82 μm y: 0.2930 μm z: 0.09686 μm



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	77.50 nm	11.17 nm	7.904 nm	94.96 nm	95.03 nm	5.124 μm	@30.0% 99.40
Line 2	<b>96.98 nm</b>	<b>18.62 nm</b>	<b>14.67 nm</b>	<b>94.96 nm</b>	<b>94.59 nm</b>	<b>5.152 μm</b>	<b>@30.0% 102.87</b>
Delta [.]							

(254,106) x: 4.96 μm y: 2.070 μm z: 0.05104 μm



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	95.06 nm	18.59 nm	14.22 nm	65.96 nm	67.51 nm	5.347 μm	@30.0% 75.68
Line 2	<b>68.78 nm</b>	<b>12.80 nm</b>	<b>9.820 nm</b>	<b>65.96 nm</b>	<b>66.36 nm</b>	<b>5.407 μm</b>	<b>@30.0% 72.67</b>
Delta [.]							

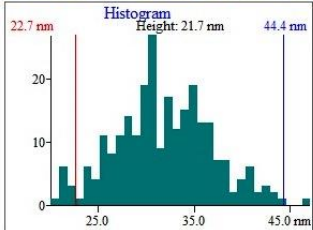
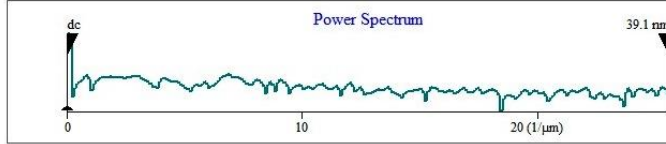
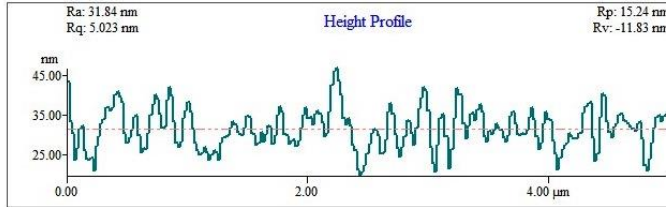
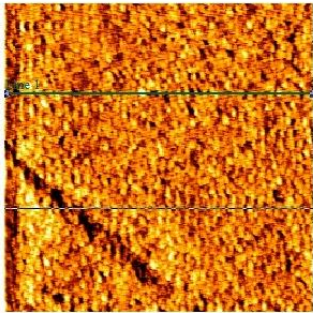


# L1 Siegen - SUBU INFN

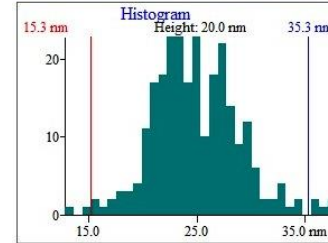
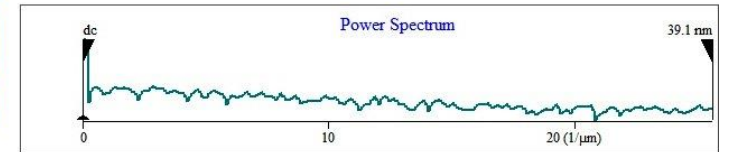
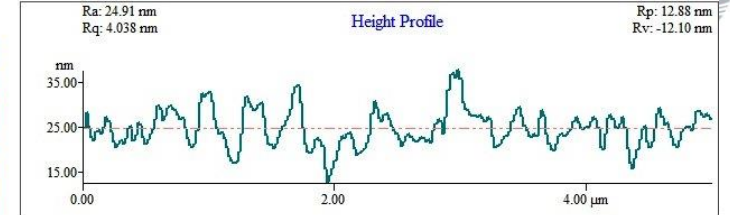
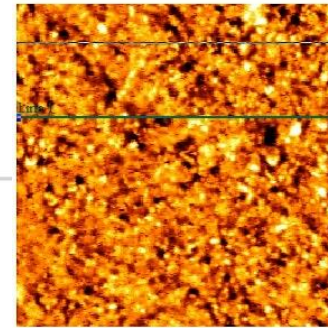
Nonirradiated



(146,86) x: 2.85 μm y: 1.680 μm z: 0.03309 μm



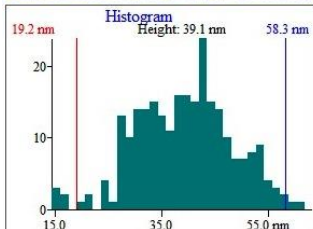
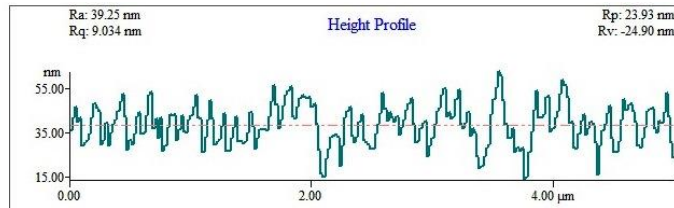
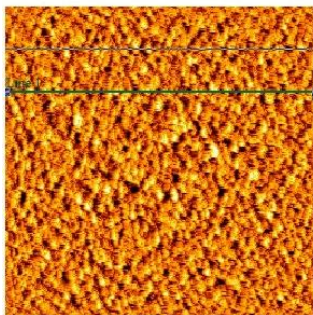
	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	27.07 nm	5.023 nm	4.008 nm	31.84 nm	31.65 nm	5.980 μm	@30.0% 34.53
Delta [.]							



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	24.98 nm	4.038 nm	3.156 nm	24.91 nm	24.59 nm	6.623 μm	@30.0% 26.94
Delta [.]							

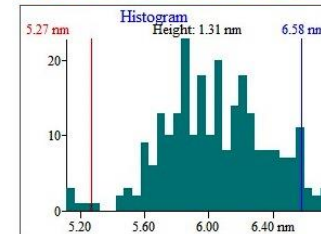
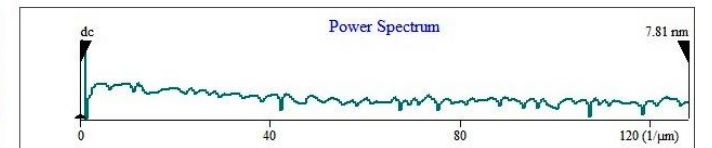
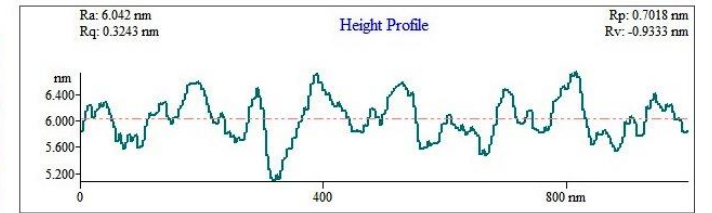
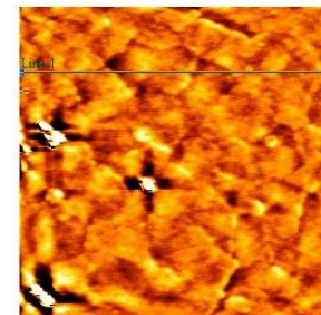
# L10 Siegen - EP

(255,221) x: 4.98 μm y: 4.316 μm z: 0.03366 μm



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	48.83 nm	9.034 nm	7.298 nm	39.25 nm	39.70 nm	29.62 μm	@30.0% 43.77
Delta [.]							

(162,203) x: 0.633 μm y: 0.7930 μm z: 0.005801 μm

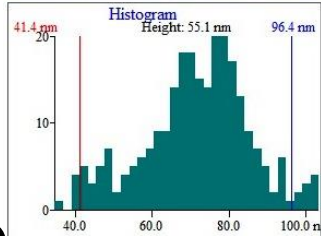
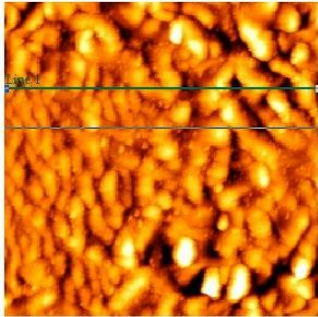


	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	1.635 nm	0.3243 nm	0.2628 nm	6.042 nm	6.043 nm	1.376 μm	@30.0% 6.22
Delta [.]							

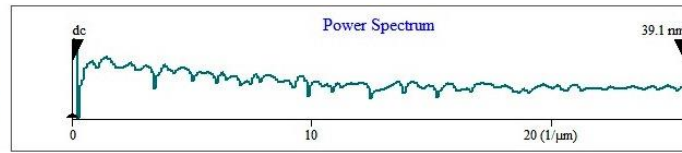
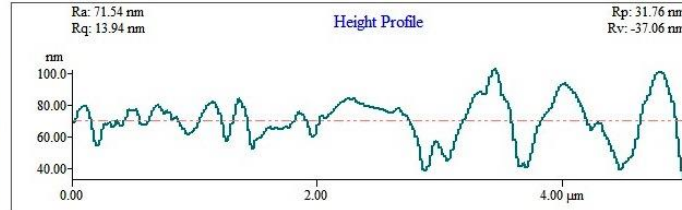


# L13 STFC - EP

(226,153) x: 4.41  $\mu\text{m}$  y: 2.988  $\mu\text{m}$  z: 0.09229  $\mu\text{m}$



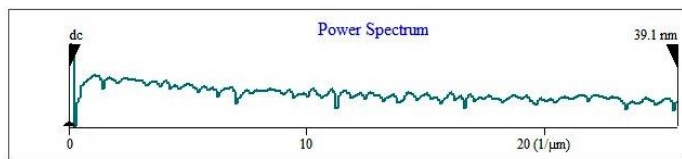
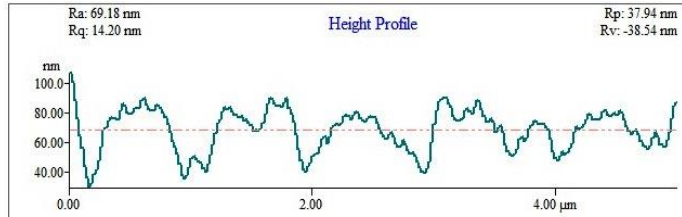
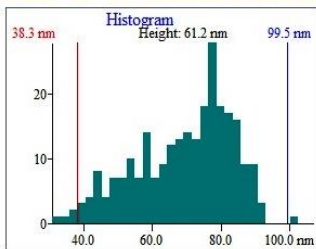
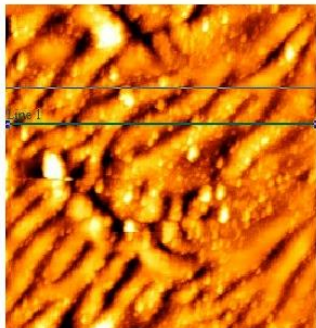
## Nonirradiated



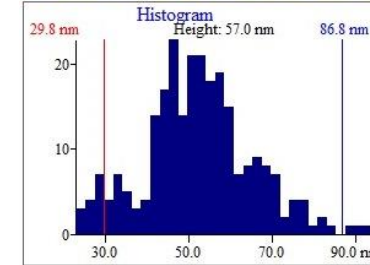
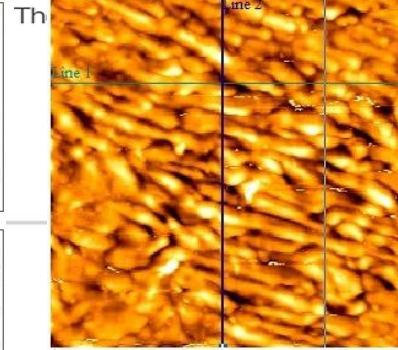
	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	68.82 nm	13.94 nm	10.92 nm	71.54 nm	72.99 nm	5.168 $\mu\text{m}$	@30.0% 78.82
Delta [.]							

# L18 STFC - EP + SUBU

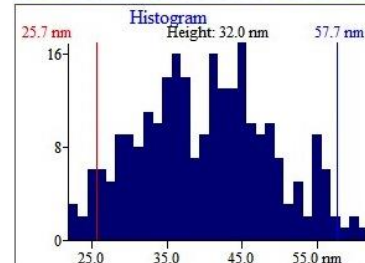
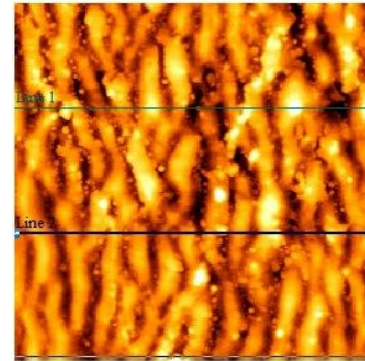
(255,191) x: 4.98  $\mu\text{m}$  y: 3.730  $\mu\text{m}$  z: 0.06423  $\mu\text{m}$



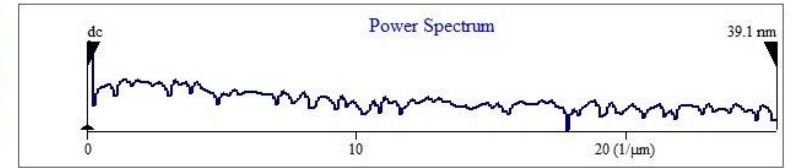
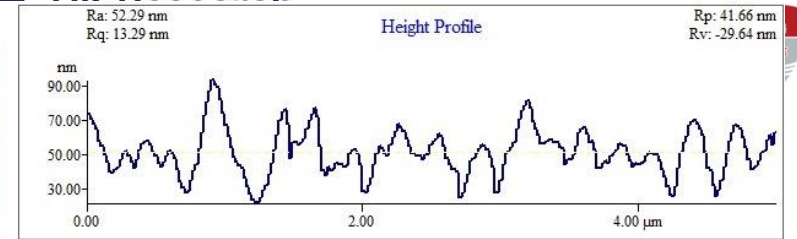
	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	76.47 nm	14.20 nm	11.76 nm	69.18 nm	72.36 nm	6.371 $\mu\text{m}$	@30.0% 78.19
Delta [.]							



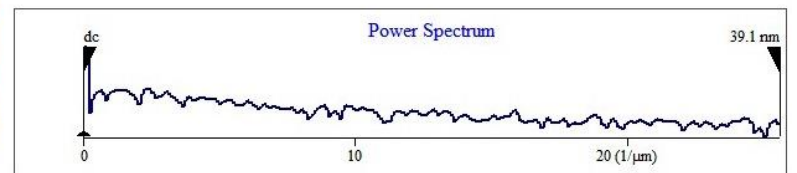
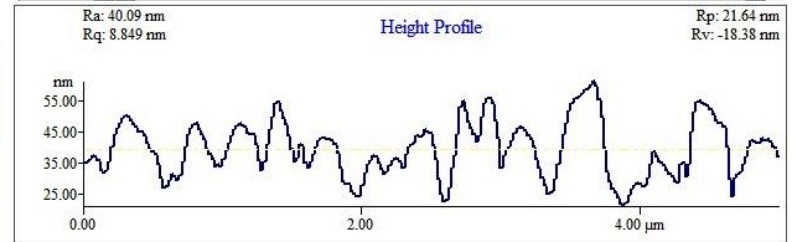
(218,3) x: 4.26  $\mu\text{m}$  y: 0.05859  $\mu\text{m}$  z: 0.03976  $\mu\text{m}$



## Irradiated



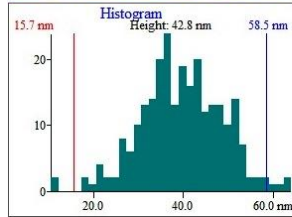
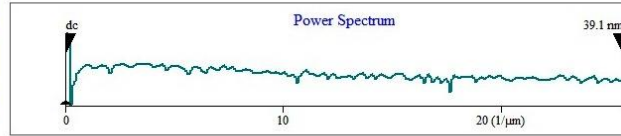
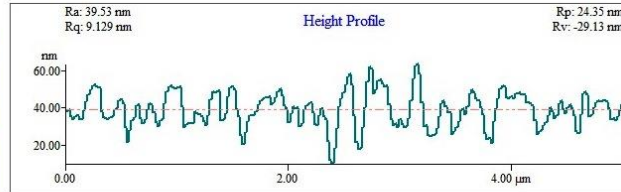
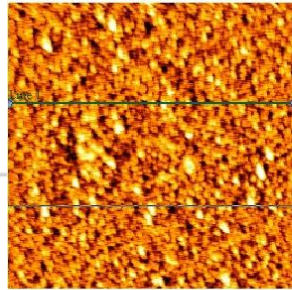
	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	51.45 nm	13.35 nm	11.31 nm	52.24 nm	54.90 nm	5.494 $\mu\text{m}$	@30.0% 62.00
Line 2	71.30 nm	13.29 nm	10.20 nm	52.29 nm	51.75 nm	5.613 $\mu\text{m}$	@30.0% 57.74
Delta [.]							



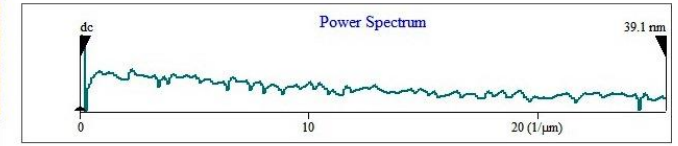
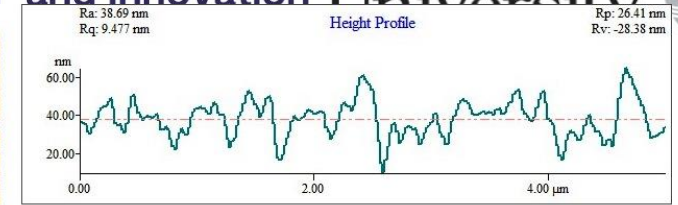
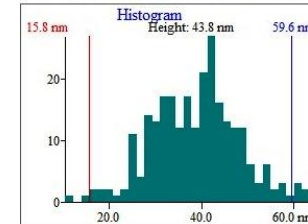
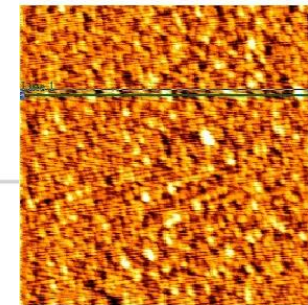
	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	88.14 nm	14.99 nm	11.63 nm	40.08 nm	38.19 nm	5.505 $\mu\text{m}$	@30.0% 46.36
Line 2	40.02 nm	8.849 nm	7.282 nm	40.09 nm	40.15 nm	5.524 $\mu\text{m}$	@30.0% 44.66
Delta [.]							



(254,74) x: 4.96  $\mu\text{m}$  y: 1.445  $\mu\text{m}$  z: 0.04057  $\mu\text{m}$



	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	53.48 nm	9.129 nm	7.272 nm	39.53 nm	39.43 nm	5.872 $\mu\text{m}$	@30.0% 44.27
Delta [.]							

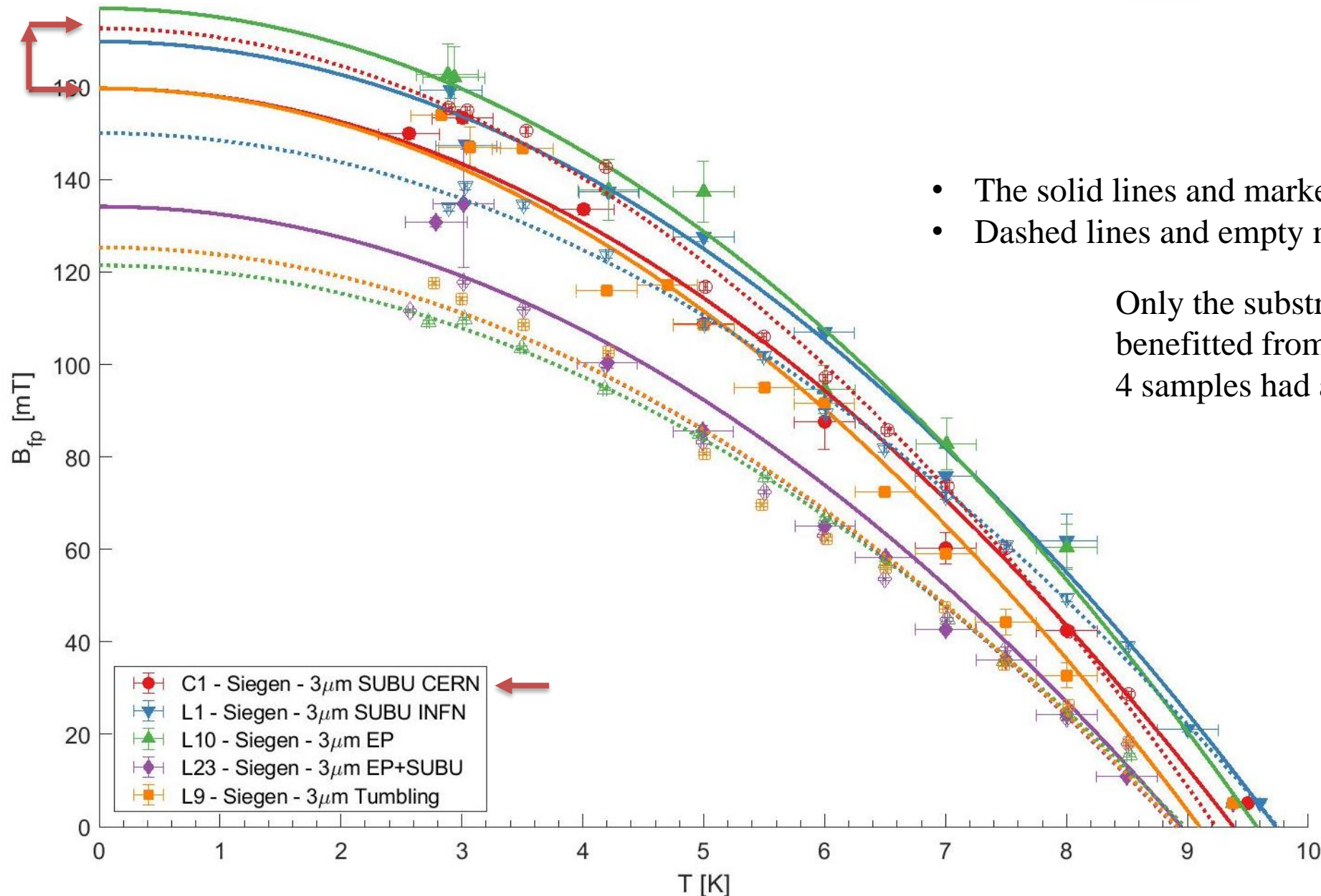


	Rp-v	Rms Rough (Rq)	Ave Rough (Ra)	Mean Ht	Median Ht	Arc length	Bearing Ratio
Line 1	54.80 nm	9.477 nm	7.551 nm	38.69 nm	39.39 nm	5.952 $\mu\text{m}$	@30.0% 43.44
Delta [.]							

## Siegen samples

- The solid lines and markers are pre laser polishing.
- Dashed lines and empty markers are post laser polishing

Only the substrate polished by SUBU CERN benefitted from the laser polishing. The other 4 samples had a reduction in  $B_{fp}(0\text{ K})$ .





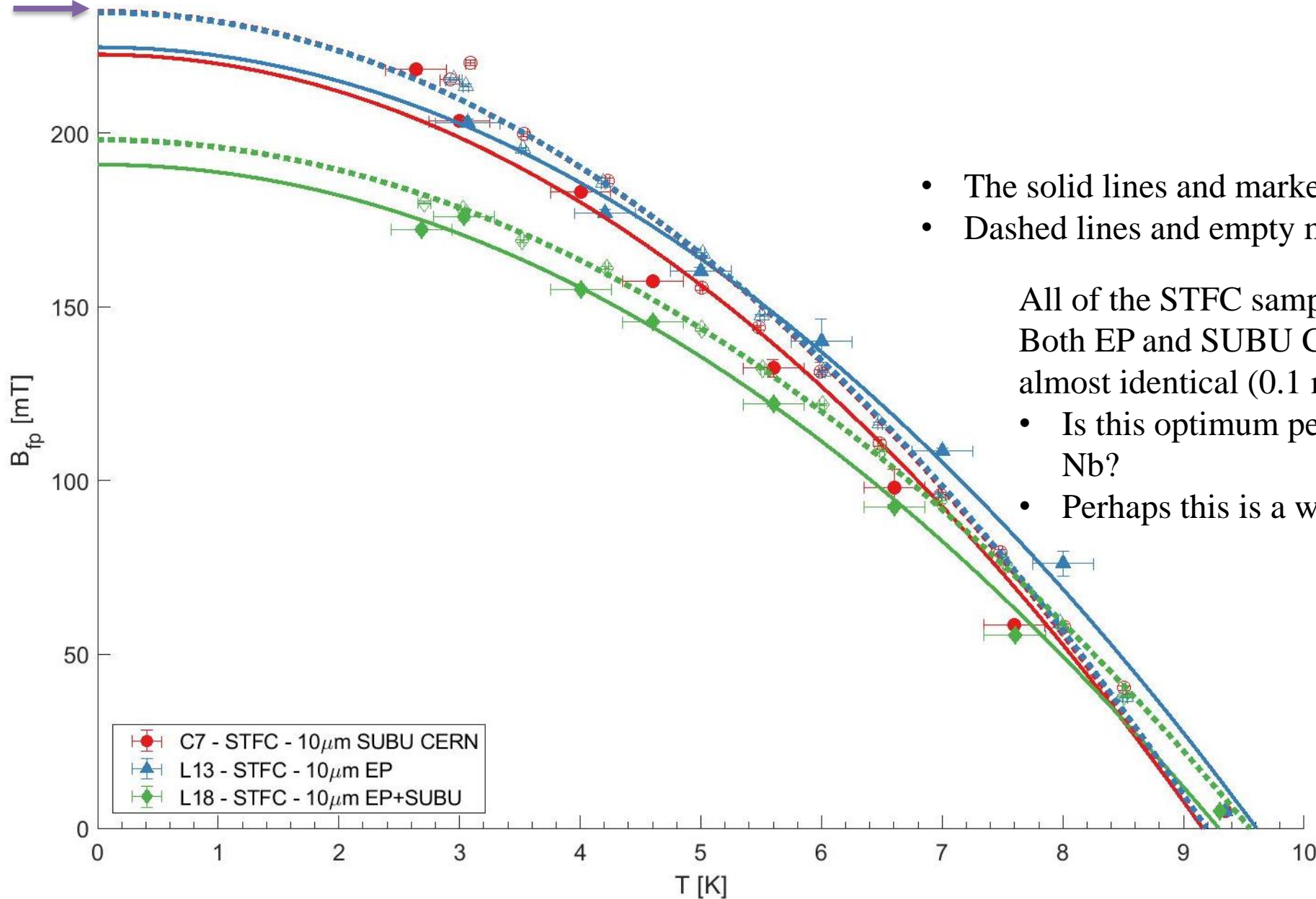
## STFC samples

- The solid lines and markers are pre laser polishing.
- Dashed lines and empty markers are post laser polishing

All of the STFC samples saw an increase in  $B_{fp}(0\text{ K})$ . Both EP and SUBU CERN polished substrates are almost identical (0.1 mT difference).

- Is this optimum performance for  $B_{fp}$  of  $10\mu\text{m}$  of Nb?
- Perhaps this is a way to improve bulk Nb cavities?

C7 and L13 behave very similar after laser polishing





# Effect of laser polishing the Nb

STFC	Siegen	INFN (with laser polishing sample surface)	
SUBU CERN ( $234.9 \pm 1.3$ )	SUBU CERN ( $152.7 \pm 2.5$ )	Tumbling ( $205.0 \pm 7.8$ )	Largest $B_{fp}(0\text{ K})$
EP ( $234.8 \pm 2.4$ )	SUBU INFN ( $150.1 \pm 2.1$ )	SUBU INFN ( $178.9 \pm 2.2$ )	
	Tumbling ( $125.4 \pm 0.9$ )	SUBU CERN ( $176.7 \pm 4.3$ )	
	EP + SUBU ( $125.3 \pm 2.1$ )		
EP + SUBU ( $198.1 \pm 6.0$ )	EP ( $121.4 \pm 2.1$ )	EP + SUBU ( $148.0 \pm 3.7$ )	Lowest $B_{fp}(0\text{ K})$

**Note:** Samples deposited at INFN only underwent 1 round of laser polishing, so the data in this table is the same as first – Just here for comparison.

# Full comparison

STFC	Siegen	INFN	
<b>SUBU CERN + LP (234.9)</b>	EP (177.0)	<b>Tumbling + LP(205.0)</b>	Largest $B_{fp}(0\text{ K})$
<b>EP + LP(234.8)</b>	<b>SUBU CERN + LP (152.7)</b>	<b>SUBU INFN + LP(178.9)</b>	
EP (224.7)	SUBU INFN (169.9)	<b>SUBU CERN + LP(176.7)</b>	
SUBU CERN (222.6)	SUBU CERN (159.7)	<b>EP + SUBU + LP(148.0)</b>	
SUBU INFN (204.8)	Tumbling (159.8)		
<b>EP + SUBU + LP (198.1)</b>	<b>SUBU INFN + LP(150.1)</b>		
EP + SUBU (191.0)	EP + SUBU (134.2)		
	<b>Tumbling + LP(125.4)</b>		
	<b>EP + SUBU + LP(125.3)</b>		
	<b>EP + LP (121.4)</b>		Lowest $B_{fp}(0\text{ K})$

**Note:** There are differences between each institute such as sample thickness, therefore each institute must be compared individually.

# Conclusion

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- Laser polishing increased the performance for the samples deposited at STFC, and the SUBU CERN sample deposited at Siegen.
- Reduction in field penetration performance in the samples deposited at Siegen.
- Reza currently has the laser treated samples from STFC and Siegen for surface analysis.
- **Questions to Artur:**
  - Was the laser polishing consistent for each sample? Any change in intensity or time taken etc? **This information is now included in the presentation**
  - Have you performed surface characterisation on these samples?
    - **Surface after irradiation is in Artur's previous IFAST (3<sup>rd</sup>) presentation, which includes AFM and optical images**
  - Would you like these samples returned once Reza has finished?

**Everyone:** Should I begin a draft of this paper? Would be beneficial?



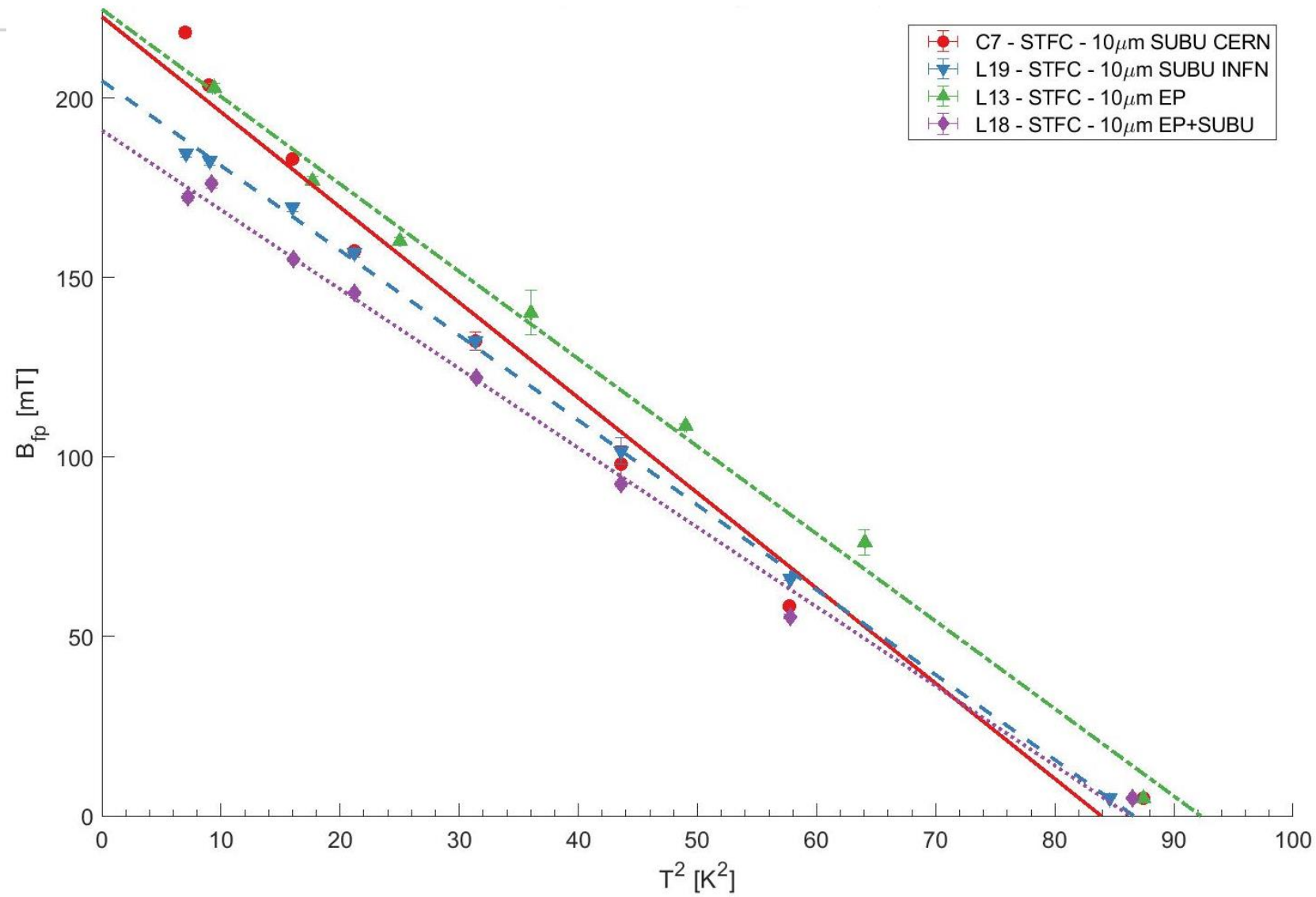


Thank you for your attention, I am happy to answer any questions.

# Results comparison

				Results from Bratislava VSM					Field penetration experiment							
				Pre laser polishing			Post laser polishing		First test				Second test - post laser polishing			
Origin	Material	Thickness	Substrate Treatment	Bperp(4.2 K) [mT]	Bpara(4.2 K) [mT]	Tc(5 mT) [K]	Bperp(4.2 K)[mT]	Bpara(4.2 K) [mT]	Tc (K)	$\Delta Tc$ (K)	Bfp(0 K) (mT)	$\Delta Bfp(0 K)$ (mT)	Tc (K)	$\Delta Tc$ (K)	Bfp(0K) (mT)	$\Delta Bfp(0K)$ (mT)
STFC	Nb	10 $\mu$ m	SUBU CERN	24.1	150.1	9.35	0	0	9.2	0.3	222.6	0.9	9.17	0.04	234.90	1.10
STFC	Nb	10 $\mu$ m	EP	22	100.3	9.35	0	0	9.6	0.4	224.7	8.5	9.19	0.09	234.80	2.40
STFC	Nb	10 $\mu$ m	EP + SUBU	17.7	61	9.3	0	0	9.3	0.3	191.0	4.3	9.55	0.29	198.10	6.00
STFC	Nb	10 $\mu$ m	SUBU INFN	17.3	73.2	9.2	0	0	9.3	0.4	204.8	6.9				
Siegen	Nb	3 $\mu$ m	SUBU CERN	15.5	49.6	9.5	0	0	9.4	0.3	159.7	1.4	9.24	0.13	172.70	2.50
Siegen	Nb	3 $\mu$ m	SUBU INFN	14.5	38	9.6	0	0	9.7	0.4	169.9	5.1	9.75	0.14	150.10	2.10
Siegen	Nb	3 $\mu$ m	Tumbling	16	38.6	9.38	0	0	9.1	0.2	159.8	1.6	8.92	0.06	125.40	0.90
Siegen	Nb	3 $\mu$ m	EP	15.5	32.7	9.38	0	0	9.6	0.4	177.0	6.1	8.98	0.15	121.43	2.10
Siegen	Nb	3 $\mu$ m	EP + SUBU	15	24.5	9.38	0	0	9.0	0.3	134.2	1.1	8.90	0.15	125.30	2.10
INFN	Nb	3 $\mu$ m	SUBU5 CERN	12	0	9.37	17	50.2	9.3	0.3	176.7	4.3				
INFN	Nb	3 $\mu$ m	Tumbling	18	0	9.48	19.1	42.5	9.7	0.4	205.0	7.8				
INFN	Nb	3 $\mu$ m	EP + SUBU5	14	0	9.37	15.5	47.2	9.2	0.3	148.0	3.7				
INFN	Nb	3 $\mu$ m	SUBU5 INFN	20	0	9.58	23.7	45	9.4	0.3	178.9	2.2				
INFN	Nb	3 $\mu$ m	EP	18	0	9.28	18.8	45.2	0.0	0.0	0.0	0.0				

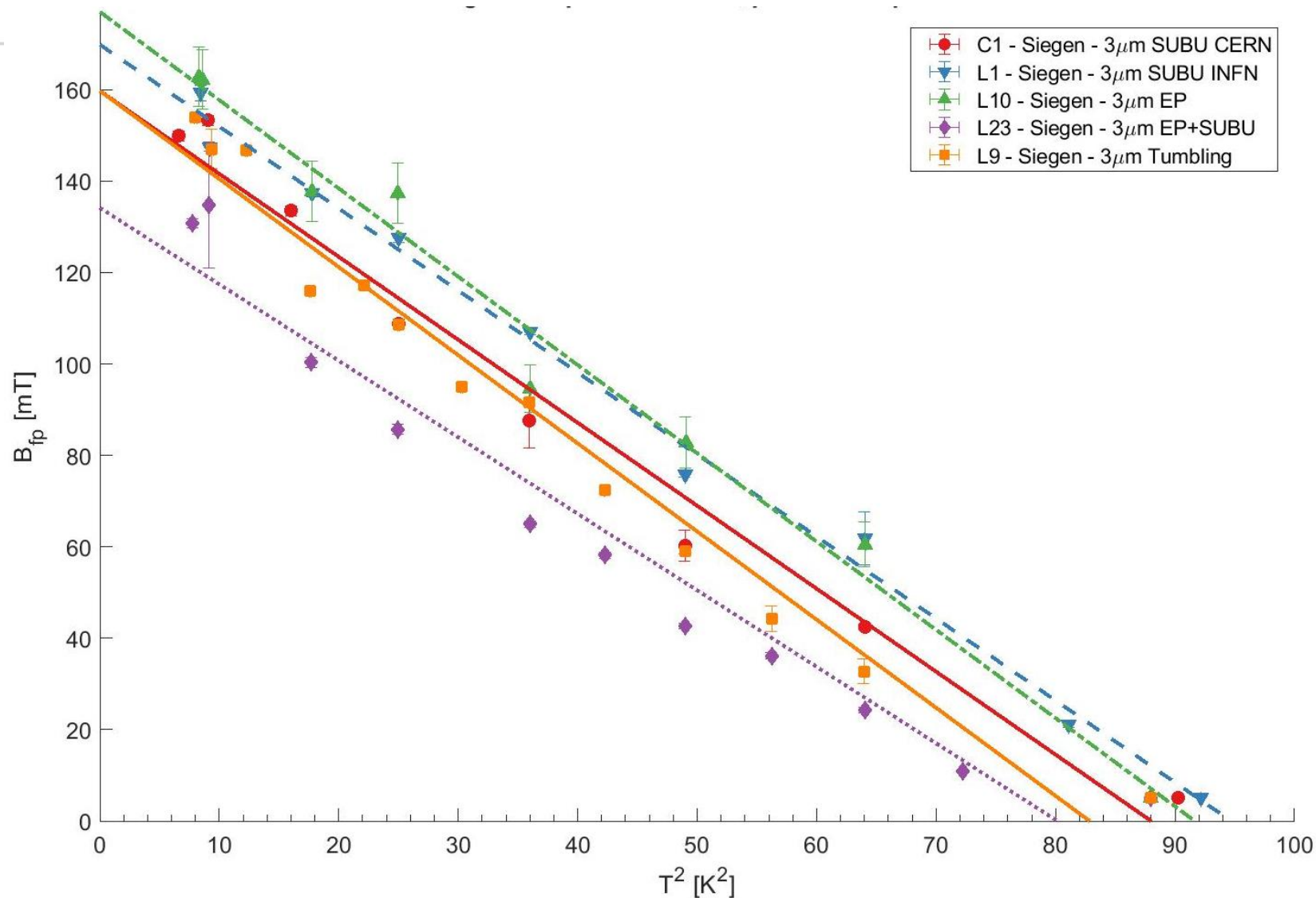
# STFC Samples, Pre – Laser treatment



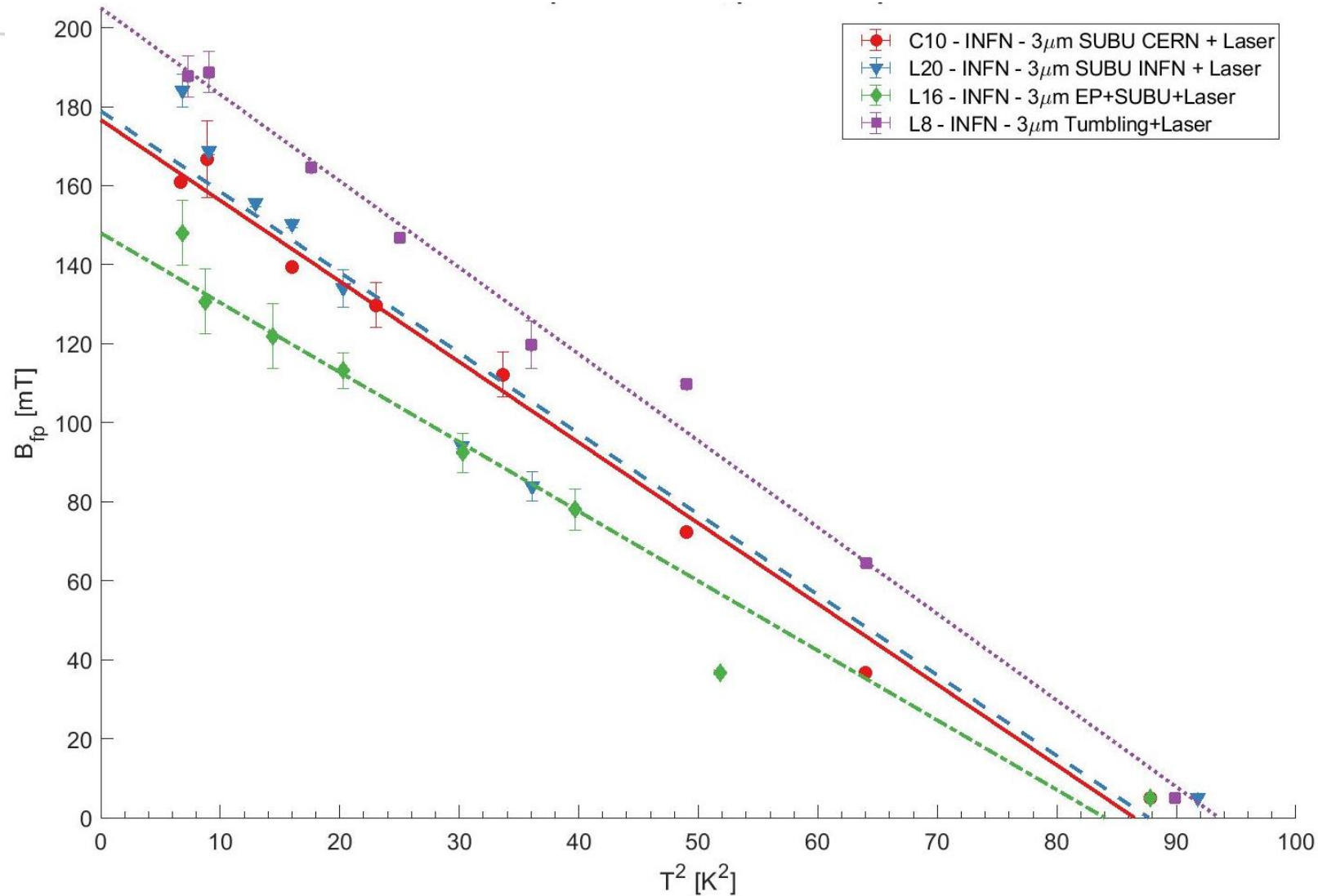




# Siegen samples, pre laser treatment

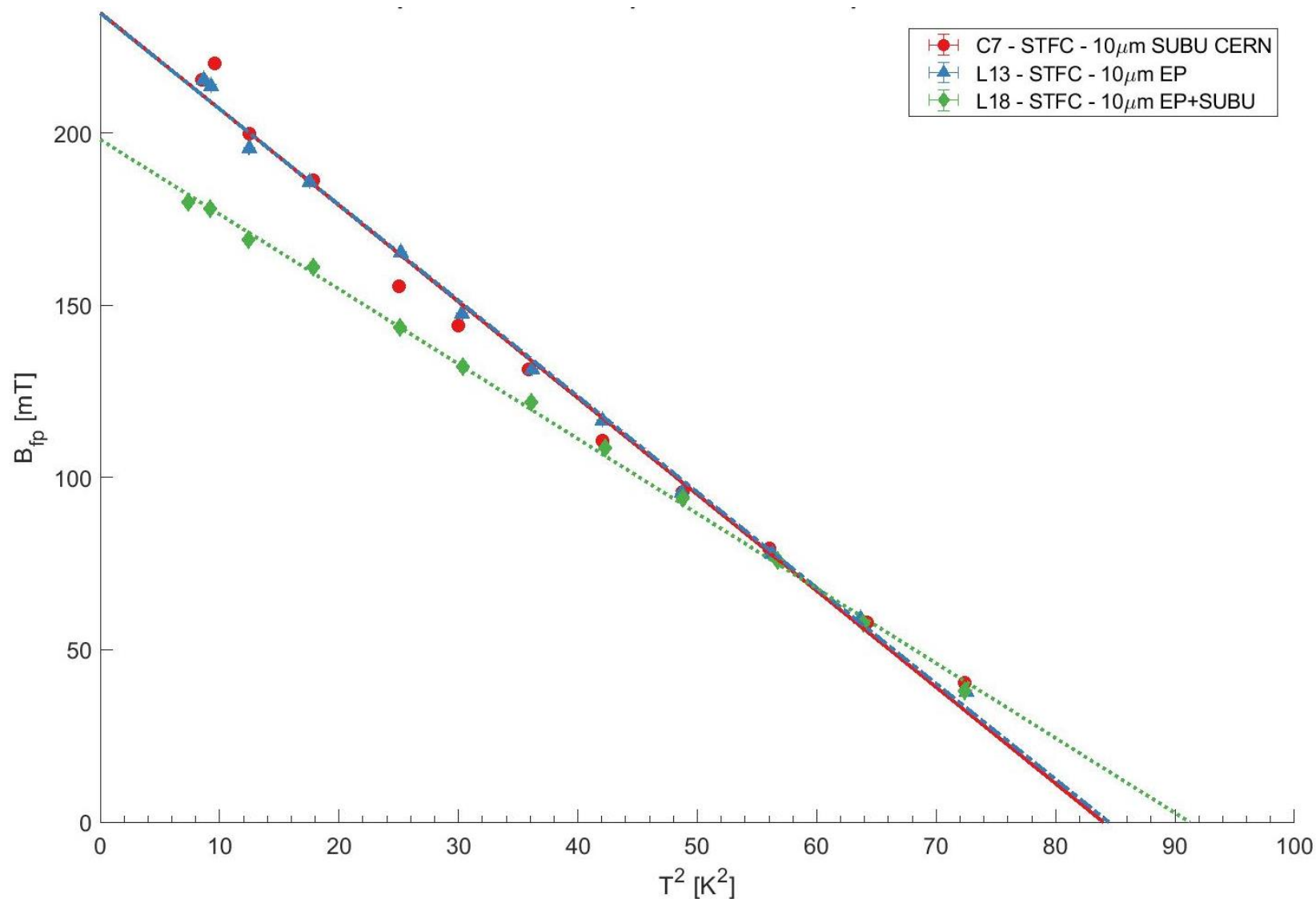


# LNL samples, 1 round of laser treatment





# STFC Samples, Post – Laser treatment







# Siegen samples, post laser treatment

